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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Shrinivasan et al.

Attorney Docket No.: NOVLP029/NVLS-000495

#6 / PDS
7-23-03
Examiner

Application No.: 10/067,520

Examiner: Not yet assigned

Filed: February 5, 2002

Group: 2811

Title: APPARATUS AND METHODS FOR
PROCESSING SEMICONDUCTOR
SUBSTRATES USING SUPERCRITICAL
FLUIDS

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on July 11, 2003 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed: Leslie Russell

Leslie Russell

**INFORMATION DISCLOSURE STATEMENT
37 CFR §§1.56 AND 1.97(b)**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The reference listed in the attached PTO Form 1449, a copy of which is attached, may be material to examination of the above-identified patent application. Applicants submit this reference in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make this reference of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This Information Disclosure Statement is: (i) filed within three (3) months of the filing date of the above-referenced application, (ii) believed to be filed before the mailing date of a first Office Action on the merits, or (iii) believed to be filed before the mailing of a first Office Action after the filing of a Request for Continued Examination under §1.114. Accordingly, it is

TECHNOLOGY CENTER 2811

believed that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. NOVLP029).

Respectfully submitted,
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Form 1449 (Modified)		Atty Docket No.	Application No.:
Information Disclosure Statement By Applicant		NOVLP029/NVLS-000495	10/067,520
(Use Several Sheets if Necessary)		Applicant: Shrinivasan et al.	
		Filing Date February 5, 2002	Group 2811

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	A	Worm et al., "Spray Member and Method for Using the Same," U.S. Publication No. US 2003/0049939, Pub Date: March 13, 2003, 42 Pages
Examiner		Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

TECHNOLOGY CENTER 2800
11-15-03
JL